

Notice of References Cited	Application/Control No. 09/994,010	Applicant(s)/Patent Under Reexamination TANIKAWA ET AL.	
	Examiner A. Dexter Tugbang	Art Unit 3729	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Chen et al., "Development and Electrical Characterization of Lead Zirconate Titanate Thick Films on Silicon Substrates", Proceedings on the 9 th IEEE Symposium on Applications of Ferroelectrics, 1994, August 1994, pages 495-498.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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